INTERNATIONAL SEARCH REPORT

mational Application No PCT/FR2004/001858

A. CLASSIFICATION OF SUBJECT MATTER IPC 7 88183/00 H01L H01L21/20 H01L21/762 According to International Patent Classification (IPC) or to both national classification and IPC B. FIELDS SEARCHED Minimum documentation searched (classification system followed by classification symbols) B81B H01L Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched Electronic data base consulted during the international search (name of data base and, where practical, search terms used) EPO-Internal, WPI Data, PAJ, INSPEC C. DOCUMENTS CONSIDERED TO BE RELEVANT Citation of document, with indication, where appropriate, of the relevant passages Category * Relevant to daim No. X FR 2 797 347 A (COMMISSARIAT ENERGIE 1-17. ATOMIQUE) 9 February 2001 (2001-02-09) 19-31,33 page 13, line 19 - page 17, line 18 figures 1-5 18,32 US 6 198 159 B1 (KATSUKI SHOUZOU ET AL) 18,32 6 March 2001 (2001-03-06) column 1, line 29 - column 2, line 13 figure 1 X Further documents are listed in the continuation of box C. Patent family members are listed in annex. Special categories of cited documents: *T* later document published after the international filing date *A* document defining the general state of the art which is not considered to be of particular relevance or priority date and not in conflict with the application but clted to understand the principle or theory underlying the invention 'E' earlier document but published on or after the international "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to filing date "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another involve an inventive step when the document is taken alone "Y" document of particular relevance; the claimed invention citation or other special reason (as specified) cannot be considered to involve an inventive step when the document is combined with one or more other such docu-O' document referring to an oral disclosure, use, exhibition or other means ments, such combination being obvious to a person skilled in the art. document published prior to the international filling date but later than the priority date claimed *&" document member of the same patent family Date of the actual completion of the international search Date of malling of the International search report 16 December 2004 28/12/2004 Name and mailing address of the ISA Authorized officer European Palent Office, P.B. 5818 Patentiaan 2 NL - 2280 HV Rijswijk Tel (+31-70) 340-2040, Tx. 31 651 epo ni,

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